

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|--|--|------------------|---------|------------------|
| S1 | 2 | ("6815162").PN. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2006/01/11 09:32 |
| S2 | 696 | (@ad<="20010312") and (438/745.ccls.) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 11:05 |
| S3 | 34 | (@ad<="20010312") and ((porous) adj (silicon)) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/11 10:49 |
| S4 | 6 | (@ad<="20010312") and ((porous) adj (silicon)) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehydes) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/11 12:08 |
| S5 | 3 | (@ad<="20010312") and ((porous) adj (silicon)) and ((hydrogen) same (terminat\$4)) and (organic) and ((thermal) adj (process\$4)) and (aldehydes) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/11 10:15 |
| S6 | 3110 | (@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/11 10:50 |
| S7 | 702 | (@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehyde) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 08:07 |
| S8 | 140 | (@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehyde) and ((thermal\$3) with (process\$3)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/11 10:51 |
| S9 | 19 | (@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehyde) and ((thermal\$3) with (process\$3)) and (stabl\$4) and (impurit\$4) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/11 10:52 |
| S10 | 702 | (@ad<="20010312") and ((silicon)) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehydes) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/11 12:08 |

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|-----|-----|--|--|----|----|------------------|
| S11 | 702 | (@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehydes) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/11 12:12 |
| S12 | 36 | (@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and ((thermal\$4) adj2 (process\$4)) and (aldehydes) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/11 12:13 |
| S13 | 9 | (@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehyde) and ((rins\$4) with (ethanol)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 08:09 |
| S14 | 3 | (@ad<="20010312") and (438/745.ccis.) and ((rins\$4) with (ethanol)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 10:05 |
| S15 | 51 | (@ad<="20010312") and ((ethyl) adj (undecylenate)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 11:04 |
| S16 | 185 | (@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 11:06 |
| S17 | 4 | (@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon)) and (438/745.ccis.) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 11:12 |
| S18 | 0 | (@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon)) and (438/745.ccis.) and ((hydrogen) adj (terminat\$4)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 11:13 |
| S19 | 0 | (@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon)) and (438/745.ccis.) and ((hydrogen) same (terminat\$4)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 11:15 |
| S20 | 1 | (@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon)) and (438/745.ccis.) and (hydrogen) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2006/01/12 11:15 |

Day : Thursday
 Date: 1/12/2006
 Time: 14:08:48


PALM INTRANET
Inventor Name Search Result

Your Search was:

Last Name = BOUKHERROUB

First Name = RABAH

| Application# | Patent# | Status | Date Filed | Title | Inventor Name |
|--------------------------|------------|--------|------------|---|-----------------------|
| 09713300 | 6677163 | 150 | 11/16/2000 | FUNCTIONALISED SILICON SURFACES, AND METHOD FOR THEIR PRODUCTION | BOUKHERROUB, RABAH |
| 09803044 | 6815162 | 150 | 03/12/2001 | PASSIVATION OF POROUS SEMICONDUCTORS | BOUKHERROUB, RABAH |
| 10012943 | 6814849 | 150 | 12/10/2001 | LUMINESCENCE STABILIZATION OF ANODICALLY OXIDIZED POROUS SILICON LAYERS | BOUKHERROUB, RABAH |
| 10714972 | Not Issued | 30 | 11/18/2003 | Functionalised silicon surfaces, and method for their production | BOUKHERROUB, RABAH |
| 10830035 | Not Issued | 71 | 04/23/2004 | Passivation of porous semiconductors | BOUKHERROUB, RABAH |
| 10972550 | Not Issued | 41 | 10/25/2004 | Luminescence stabilization of anodically oxidized porous silicon layers | BOUKHERROUB, RABAH |
| 60244929 | Not Issued | 159 | 11/02/2000 | Photooxide patterning on silicon | BOUKHERROUB, RABAH |

Inventor Search Completed: No Records to Display.

| | | |
|--------------------------|---|---|
| Search Another: Inventor | <input style="width: 100%; border: 1px solid black; height: 1.2em; font-size: 0.9em;" type="text" value="boukherroub"/> | <input style="width: 100%; border: 1px solid black; height: 1.2em; font-size: 0.9em;" type="text" value="rabah"/> <input style="border: 1px solid black; padding: 2px 10px; font-size: 0.8em;" type="button" value="Search"/> |
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Day : Thursday
Date: 1/12/2006

Time: 14:09:22

PALM INTRANET**Inventor Name Search Result**

Your Search was:

Last Name = WAYNER

First Name = DANIAL

| Application# | Patent# | Status | Date Filed | Title | Inventor Name |
|---------------------------------|--------------------------------|--------|------------|---|-------------------------|
| <u>09713300</u> | <u>6677163</u> | 150 | 11/16/2000 | FUNCTIONALISED SILICON SURFACES, AND METHOD FOR THEIR PRODUCTION | WAYNER, DANIAL D. M. |
| <u>10714972</u> | Not Issued | 30 | 11/18/2003 | Functionalised silicon surfaces, and method for their production | WAYNER, DANIAL D. M. |
| <u>10972550</u> | Not Issued | 41 | 10/25/2004 | Luminescence stabilization of anodically oxidized porous silicon layers | WAYNER, DANIAL D. M. |
| <u>60228770</u> | Not Issued | 159 | 08/30/2000 | Photopatterning of organics on silicon surfaces using a photo-oxide mask | WAYNER, DANIAL D. M. |
| <u>60612168</u> | Not Issued | 159 | 09/23/2004 | Method and materials for the deposition and encapsulation of nanocrystals on surfaces | WAYNER, DANIAL D. M. |
| <u>09691117</u> | Not Issued | 161 | 10/19/2000 | Nano-scale structures on surfaces | WAYNER, DANIAL D.M. |
| <u>09803044</u> | <u>6815162</u> | 150 | 03/12/2001 | PASSIVATION OF POROUS SEMICONDUCTORS | WAYNER, DANIAL D.M. |
| <u>10012943</u> | <u>6814849</u> | 150 | 12/10/2001 | LUMINESCENCE STABILIZATION OF ANODICALLY OXIDIZED POROUS SILICON LAYERS | WAYNER, DANIAL D.M. |
| <u>10830035</u> | Not Issued | 71 | 04/23/2004 | Passivation of porous semiconductors | WAYNER, DANIAL D.M. |
| <u>60244929</u> | Not Issued | 159 | 11/02/2000 | Photooxide patterning on silicon | WAYNER, DANIAL D.M. |
| <u>60654517</u> | Not Issued | 20 | 02/22/2005 | Microfluidic microarray with high surface area active response | WAYNER, DANIAL D.M. |
| <u>07775556</u> | Not Issued | 161 | 10/15/1991 | ELECTROCHEMICAL DEGRADATION OF CHLOROPHENOLS | WAYNER, DANIAL D.M. |

Inventor Search Completed: No Records to Display.

Day : Thursday
 Date: 1/12/2006
 Time: 14:09:54


PALM INTRANET
Inventor Name Search Result

Your Search was:

Last Name = LOCKWOOD

First Name = DAVID

| Application# | Patent# | Status | Date Filed | Title | Inventor Name |
|---------------------------------|-----------------------------------|---------------|-------------------|---|----------------------|
| <u>09890815</u> | <u>Not Issued</u> | 125 | 02/06/2002 | Computer borrow and loan securities auction system | LOCKWOOD, DAVID |
| <u>60163303</u> | <u>Not Issued</u> | 159 | 11/03/1999 | COMPUTER BORROW AND LOAN SECURITIES AUCTION SYSTEM | LOCKWOOD, DAVID |
| <u>06514597</u> | <u>4529161</u> | 150 | 07/18/1983 | BREAK-AWAY MIRROR BRACKET | LOCKWOOD, DAVID G. |
| <u>09695798</u> | <u>6518603</u> | 150 | 10/25/2000 | SELECTIVE ELECTROCHEMICAL PROCESS FOR CREATING SEMICONDUCTOR NANO- AND MICRO-PATTERNS | LOCKWOOD, DAVID J. |
| <u>09803044</u> | <u>6815162</u> | 150 | 03/12/2001 | PASSIVATION OF POROUS SEMICONDUCTORS | LOCKWOOD, DAVID J. |
| <u>10830035</u> | <u>Not Issued</u> | 71 | 04/23/2004 | Passivation of porous semiconductors | LOCKWOOD, DAVID J. |
| <u>09196641</u> | <u>6284671</u> | 150 | 11/19/1998 | SELECTIVE ELECTROCHEMICAL PROCESS FOR CREATING SEMICONDUCTOR NANO- AND MICRO-PATTERNS | LOCKWOOD, DAVID J. |
| <u>60013336</u> | <u>Not Issued</u> | 159 | 03/13/1996 | LIGHT EMITTING DEVICES BASED ON SEMICONDUCTOR/DIELECTIRC SUPERLATTICE PHOSPHORS | LOCKWOOD, DAVID J. |
| <u>10012943</u> | <u>6814849</u> | 150 | 12/10/2001 | LUMINESCENCE STABILIZATION OF ANODICALLY OXIDIZED POROUS SILICON LAYERS | LOCKWOOD, DAVID JOHN |
| <u>10972550</u> | <u>Not Issued</u> | 41 | 10/25/2004 | Luminescence stabilization of anodically oxidized porous silicon layers | LOCKWOOD, DAVID JOHN |
| <u>10381746</u> | <u>Not Issued</u> | 41 | 08/22/2003 | Electrosurgery systems | LOCKWOOD, DAVID L. |
| <u>06068945</u> | <u>D260635</u> | 150 | 08/23/1979 | SPLIT CORE CURRENT | LOCKWOOD, |

| | | | | | |
|----------|------------|-----|------------|-----------------------------|-----------------------|
| | | | | TRANSFORMER | DAVID L. |
| 06647017 | 4672780 | 150 | 09/04/1984 | BUILDING PANELS | LOCKWOOD, DAVID N. |
| 06752027 | Not Issued | 161 | 07/05/1985 | DRILL BIT SHARPENING DEVICE | LOCKWOOD, DAVID N. |
| 06826061 | 4658549 | 150 | 01/21/1986 | DRILL BIT SHARPENING DEVICE | LOCKWOOD, DAVID N. |
| 07019330 | 4776139 | 150 | 02/26/1987 | BUILDING PANELS | LOCKWOOD, DAVID N. |
| 07217771 | 4862652 | 150 | 07/11/1988 | BUILDING PANELS | LOCKWOOD, DAVID N. |
| 07286621 | 4916867 | 250 | 12/19/1988 | DRILL BIT SHARPENER | LOCKWOOD, DAVID N. |

Inventor Search Completed: No Records to Display.

| | | |
|---------------------------------|---------------------------------------|------------------------------------|
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